## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Kenji WATANABE et al.

Serial Number: Not yet assigned

(§371 of international application No. PCT/JP2004/000711)

Filed: July 25, 2005

For: MAPPING-PROJECTION-TYPE ELECTRON BEAM APPARATUS

FOR INSPECTING SAMPLE BY USING ELECTRONS EMITTED

FROM THE SAMPLE

Attorney Docket Number: 052886

Customer Number: 38834

## PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 July 25, 2005

Sir:

Prior to calculation of the filing fee and examination of this application, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.